U.S. Patent Application No.: 10/663,691 INVENTOR: Yasuhisa Inao, et al.

TITLE: MASK, EXPOSURE APPARATUS, AND EXPOSURE METHOD

FIG. 6 (Replacement Sheet) **Docket No.:** 00684.003542.



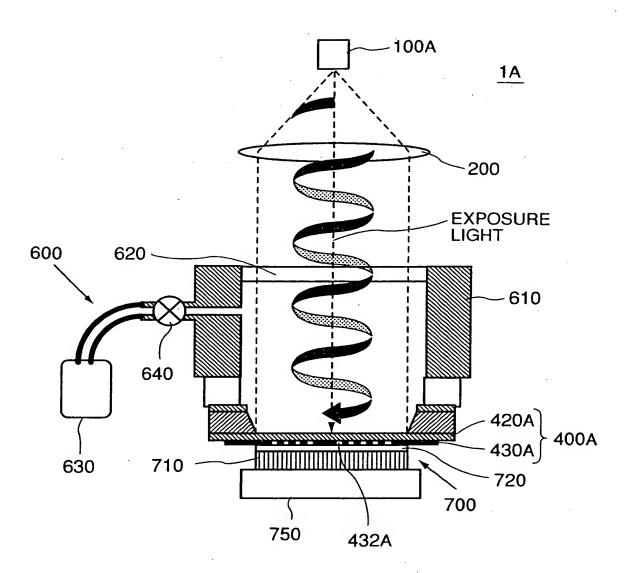


FIG. 6

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FIG. 7A and FIG. 7B (Replacement Sheet) **Docket No.:** 00684.003542.





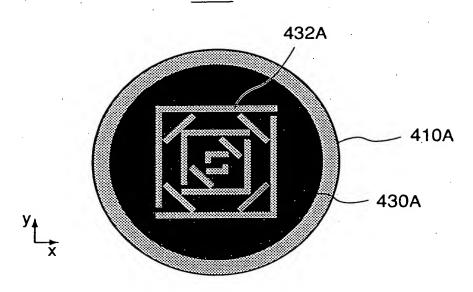
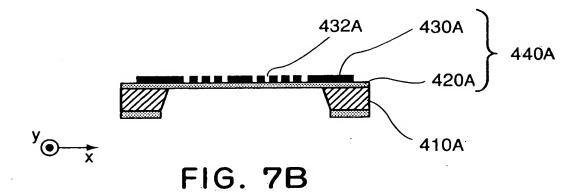


FIG. 7A



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FIG. 9 (Replacement Sheet) Docket No.: 00684.003542.



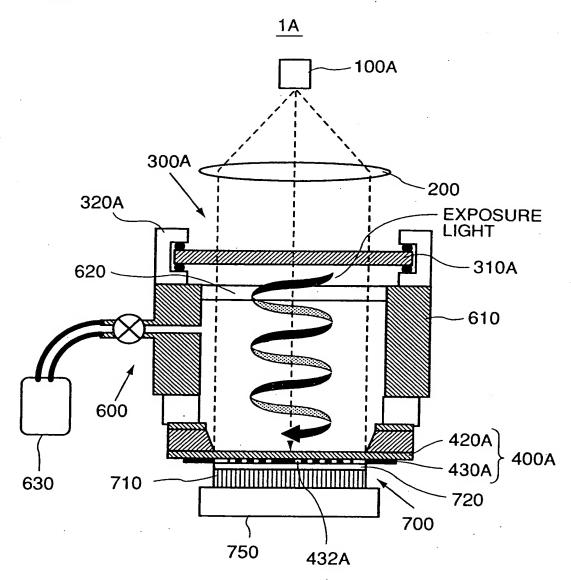


FIG. 9